



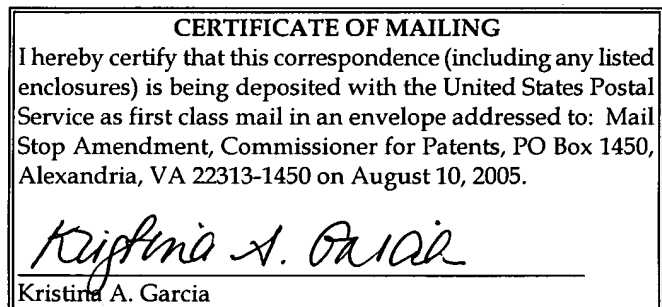
IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

|                          |   |                         |
|--------------------------|---|-------------------------|
| In re application of:    | § | Attorney Docket No.     |
| Bor-Wen Chan, et al.     | § | 2001.0714C / 24061.605  |
|                          | § |                         |
| Serial No.: 10/755,498   | § | Customer No. 42717      |
|                          | § |                         |
| Filed: January 12, 2004  | § | Group Art Unit: 1765    |
|                          | § |                         |
| For: METHOD OF FORMING A | § | Examiner: Duy-Vu N. Deo |
| STACKED CAPACITOR        | § |                         |
| STRUCTURE WITH INCREASED | § | Confirmation No.: 1284  |
| SURFACE AREA FOR A DRAM  | § |                         |
| DEVICE                   | § |                         |

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:



**AMENDMENT UNDER 37 CFR §1.111**

This Amendment is submitted in reply to the Office Action mailed on May 12, 2005.  
(Please see the pages that follow).